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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **Katsuto TANAHASHI et al.**

Group Art Unit: **2826**

Serial No.: **10/743,793**

Examiner: **Johannes P. Mondt**

Filed: **December 24, 2003**

Confirmation No.: **9788**

For: **SEMICONDUCTOR SUBSTRATE AND MANUFACTURING
METHOD THEREOF**

Attorney Docket Number: **032206**

Customer Number: **38834**

RESPONSE TO RESTRICTION REQUIREMENT

Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

Date: May 20, 2005

Sir:

This paper is submitted in response to the Official Action dated April 21, 2005.

In the Action, restriction is required between Group I, Claims 1-14 and Group II, Claims 15-18.

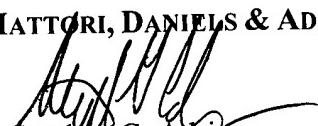
Applicants hereby elect the subject matter of Group I, Claims 1-14 for prosecution in this application. This election is made without traverse, and it is understood that Applicants' rights to the filing of a divisional application directed to the non-elected subject matter under 35 U.S.C. §120 and 35 U.S.C. §121 are retained.

Response to Restriction Requirement
Serial No. 10/743,793
Attorney Docket No. 032206

If this paper is not timely filed, Applicant(s) respectfully petition(s) for an appropriate extension of time. The fees for such an extension or any other fees that may be due with respect to this paper may be charged to Deposit Account No. 50-2866.

Respectfully submitted,

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